



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroyuki NAGASAKA et al.

Group Art Unit: 2851

Application No.: 10/594,963

Examiner: M. ASFAW

Filed: November 14, 2006

Docket No.: 129616

For: PLATE MEMBER, SUBSTRATE HOLDING DEVICE, EXPOSURE APPARATUS
AND METHOD, AND DEVICE MANUFACTURING METHOD

REQUEST FOR RECONSIDERATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the February 20, 2009 Office Action, the shortened statutory period for
reply having been extended by the attached Petition for Extension of Time, reconsideration of
the rejection is respectfully requested in light of the following remarks.